

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Satoshi MATSUMOTO et al.)	Confirmation No.: 8192
)	
Application No.: 10/518,392)	Group Art Unit: 2855
)	
Filed: July 25, 2005)	Examiner: Gail K. Verbitsky
)	
For: LASER PROCESSING APPARATUS,)	
LASER PROCESSING)	
TEMPERATURE MEASURING)	
APPARATUS, LASER)	
PROCESSING METHOD, AND)	
LASER PROCESSING)	
TEMPERATURE MEASURING)	
METHOD)	

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Window, Mail Stop Amendment
Alexandria, VA 22314

Sir:

AMENDMENT

In response to the Office Action dated February 24, 2009, the period for response to which runs through May 26, 2009 (May 24, 2009 being a Sunday and May 25, 2009 being a Federal Holiday), please amend the above-identified application as follows.